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35.C13630,

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASAAKI IWANE ET AL.

Application No.: 09/346,678,

Filed: July 2, 1999

For: CRYSTAL GROWTH PROCESS,
SEMICONDUCTOR DEVICE,
AND ITS PRODUCTION
PROCESS

)
: Examiner: J. Diaz
)
: Group Art Unit: 2815
)

: September 25, 2000

*10/Electronic
J. Steptae
9/30/00*

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated September 8, 2000, Applicants elect to proceed initially with examination of Invention II, Claims 7-9.

Applicants respectfully request favorable consideration on the merits and early passage to issue of the elected claims.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100 or by

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facsimile at (212) 218-2200. All correspondence should
continue to be directed to our address given below.

Respectfully submitted,

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Attorney for Applicants

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